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Joseph F. Hetz - Reg. No. 41,070

Name of Applicant, Assignee or  
Registered Representative

Signature

Our Case No. 10519-57

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)		
Herner et al.	)		
Serial No.:	09/928,975	)	Examiner: T. Magee
Filed:	August 13, 2001	)	Group Art Unit: 2811
For:	Low Resistivity Titanium Silicide on Heavily Doped Semiconductor	)	TECHNOLOGY CENTER 2800

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**AMENDMENT AND RECORD OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the Office Action mailed January 6, 2003.

**IN THE CLAIMS**

Please amend Claim 8 as follows. Appendix A (at Tab A) contains a marked-up version of this claim showing the changes being made.